



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Toshihiko TSUJI et al.

Group Art Unit: 2851

Application No.: 10/603,807

Examiner: H. Nguyen

Filed: June 26, 2003

Docket No.: 116370

For: EXPOSURE METHOD AND EXPOSURE APPARATUS

**AMENDMENT UNDER 37 C.F.R. §1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the August 27, 2004 Office Action, the period for reply being extended by the attached one-month Petition for an Extension of Time, please consider the following:

**Amendments to the Claims**, as reflected in the listing of claims.